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Application No.:  
10/080,793

Form P449 (Modified)

Information Disclosure  
Statement By Applicant

(Use Several Sheets if Necessary)

Atty Docket No.  
SUN1P231C1

Applicant:  
Click Jr. et al.  
Filing Date  
2/20/2003

Group  
2122

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
CP	A	6,202,208B1	3/2001	Holiday, Jr.	717	11	
	B	6,074,432	6/2000	Guccione	717	2	
	C	5,822,591	10/1998	Hochmuth	717	5	
	D	5,659,751	8/1997	Heninger	709	305	
	E	5,553,286	9/1996	Lee	717	5	
	F						
	G						
	H						
	I						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	J							
	K							
	L							
	M							
	N							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	O	
	P	
	Q	

Examiner

*Click*

Date Considered

02/18/05

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	<b>Atty Docket No.</b> SUN1P231C1	<b>Application No.:</b> 10/080,793
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## U.S. Patent Documents

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**Foreign Patent or Published Foreign Patent Application**

## Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
CP	A	Rayside et al., "Change and Adaptive Maintenance Detection in Java Software Systems," Proceedings, IEEE Fifth Working Conference on Reverse Engineering, 1998, pp. 10-19.

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.